

JFW



## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re: PATENT application of )  
 Toru TAKAYAMA, et al. )  
 Serial No. 10/787,165 ) Group Art Unit: 1763  
 Filed: February 27, 2004 ) Examiner: G. Goudreau  
 For: METHOD FOR PEELING OFF )  
 SEMICONDUCTOR ELEMENT AND METHOD )  
 FOR MANUFACTURING SEMICONDUCTOR )  
 DEVICE

**CERTIFICATE OF MAILING**

I hereby certify that this correspondence is being deposited with  
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 P. O. Box 1450, Alexandria VA 22313-1450, on July 6, 2005

**REQUEST FOR STATUS**

Honorable Commissioner of Patents

P. O. Box 1450

Alexandria VA 22313-1450

Sir:

To date the undersigned attorney of record has received no action in the above-identified patent application. Please provide the undersigned with a status report of the application in writing.

Respectfully submitted,




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Eric J. Robinson  
 Reg. No. 38,285

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